



PATENT

Case Docket No. ASMINT.002C3

Date: July 29, 2003

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s) : Granneman et al.
Appl. No. : Unknown 10 603 515
Filed : June 24, 2003
For : METHOD AND APPARATUS
FOR SUPPORTING A
SEMICONDUCTOR WAFER
DURING PROCESSING
Examiner : Unknown
Group Art Unit : Unknown

I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on

July 29, 2003

(Date)

Adeel S. Akhtar, Reg. No. 41,394

TRANSMITTAL LETTER

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application are:

- (X) An Information Disclosure Statement.
- (X) A PTO Form 1449 with one (1) reference.
- (X) The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Account No. 11-1410.
- (X) Return prepaid postcard.

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